

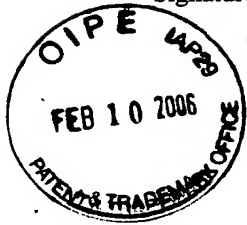
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Typed or Printed Name of Person Mailing Paper or Fee: Linda West

Signature: Linda M. West



PATENT  
DOCKET NO. P1573

IN THE  
UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANT: JENNIFER WANG

SERIAL NO.: 10/782,538

EXAMINER: VINH, LAN

FILED: FEBRUARY 18, 2004

ART UNIT: 1765

TITLE: METHOD OF DRY PLASMA ETCHING SEMICONDUCTOR  
MATERIALS

MAIL STOP AMENDMENT  
COMMISSIONER FOR PATENTS  
P.O. BOX 1450  
ALEXANDRIA, VA 22313-1450

TRANSMITTAL LETTER

Dear Sir:

In connection with the above-referenced patent application, transmitted herewith are the following:

1. Amendment in Response to Office Action (12 pages); and
2. Post card in acknowledgment of receipt of all transmitted material.

Please date stamp and return the enclosed post card to the undersigned in acknowledgment of receipt of all transmitted materials.

Respectfully submitted,

A handwritten signature in black ink, appearing to read 'F. David LaRiviere', written over a horizontal line.

F. David LaRiviere

Reg. No. 27,207

CKC/FDL//kr  
February 10, 2006  
LARIVIERE, GRUBMAN & PAYNE, LLP  
P.O. Box 3140  
Monterey, CA 93942-3140  
(831) 649-8800

02 - 13 - 06

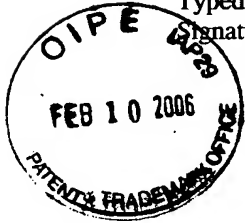
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AMENDMENT IN RESPONSE TO OFFICE ACTION

To the Commissioner:

In response to the Office Action dated November 14, 2005, the Applicant respectfully requests favorable consideration of the below submitted amendment and remarks.

AMENDMENT

IN THE SPECIFICATION

Please insert the following paragraph into the Specification immediately following the TITLE and preceding the TECHNICAL FIELD. All subsequent paragraphs shall be renumbered to the next higher number.